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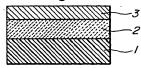
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- (71) Applicant: Toppan Printing Co., Ltd. Talto-ku, Tokyo 110-0016 (JP)
- (72) Inventors:
- · KOMORI, Tsunenori Toppan Printing Co., Ltd. Tokyo 110-0016 (JP)

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 - · SEKIGUCHI, Mamoru Toppan Printing Co., Ltd. Tokyo 110-0016 (JP)
 - · SASAKI, Noboru Toppan Printing Co., Ltd.
 - Tokyo 110-0016 (JP) . SHIMATANI, Ken Toppan Printing Co., Ltd.
- Tokyo 110-0016 (JP)
- . KOIZUMI, Furnitake Toppan Printing Co., Ltd. Tokyo 110-0016 (JP)
- (74) Representative: Sherrard-Smith, Hugh et al. Appleyard, Lees & Co. 15 Clare Road Hallfax, HX1 2HY West Yorkshire (GB)
- (54)VAPOR DEPOSITION FILM AND PACKAGING MATERIAL
- A vapor deposition film comprises a substrate made of a plastic material, a primer layer made from a composition comprising a specific trifunctional organosilane or a hydrolysate of the organosilane, an acryl

polvol and an isocvanate compound, and an inorganic oxide vapor deposition layer to a thickness of 5~300nm. formed by successive lamination on at least one side of the substrate. Also, packaging materials and packages which employ the film are provided.



Description

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TECHNICAL FIELD

[0001] The present invention relates to a vapor deposition film with excellent achesion of a vapor deposition layer and to a packeging material using the same, and more specifically relates to packaging materials used for packaging in the fields of foods, non-foods, medicines and so forth, as well as a vapor deposition film used for such packaging materials, and particularly to packaging materials used in packaging flietds which require boiling sterilization, retort sterilization, autoclave sterilization and the like, and to a vapor deposition film used for such packaging materials.

BACKGROUND ART

[0002] In recent years packaging materials used for packaging of foods, non-foods, medicines, etc. must have the ability to block the effects of oxygen, water vapor and other gases which permeate the packaging materials and alter the quality of their contents, in order to prevent such alteration in the contents and maintain their functions and properties. Hence there is a demand for packaging materials with gas barrier properties which block these gases. Commonly used packaging materials to date have therefore employed metal foils of aluminum, etc. as gas barrier layers, because they are largely unaffected by temperature and humidity.

[0003] Nevertheless, while packaging materials employing aluminum and other metal folls have excellent gas barrier properties, problems have existed because of their drawbacks, which include the fact that such packaging materials are not transparent enough to allow visual verification of their contents, that they must be treated as non-combustibles when discoved of after use, and that metal detectors cannot be used for their examination.

[0004] As packaging materials designed to overcome these drawbacks there have been developed films wherein silicon oxide, aluminum oxide, magnesium oxide or another inorganic oxide vapor deposition film has formed on a polymer film by a forming means such as vacuum vapor deposition or sputtering, as is described, for example, in U. S. Patent No. 3.442.686, Japanese Examined Patent Publication No. Sho 63-28017, etc. Such vapor deposition films are known to be transparent with gas barrier propriets against oxygen, water vapor and the like, and are thus suitable as packaging materials which provide both the transparency and gas barrier properties which are unobtainable with metal folia set.

Ø [0005] However, atthough such films are suitable for the packaging materials described above, virtually none of them can be used as vapor deposition films alone for packaging containers and packaging materials. This is because packages are completed by undergoing post-processing after vapor deposition, which involves various steps such as printing of characters and images on the vapor deposition film surface, or attachment to other films, etc. and shaping into packages for containers and the like. In particular, because packaging materials subjected to botting sterilization are sterilization.

[0006] When attempts have been made to use these types duplication with seal milking in combination with seal milking the properties as which are then the other device to the subject to bostiling shelf install not or retor at settliffication, peeling not of the vapor deposition is supported by the properties are also reduced at these so that of the vapor deposition is properties are also reduced at these so that of the value of the vapor deposition is propertied as a large to deposition is propertied as a large to deposit on the value of the val

[0007] In other words, the conditions for packaging materials in such situations include transparency which allows the contents to be directly viewed, high gas barrier properties to block gases which adversely affect the contents, and resistance to sterilization transment with no deterioration of the gas barrier properties and no peeling after boiling sterilization, retort sterilization and autoclave sterilization; at present, however, no packaging materials have been 5 discovered which saidly all of these conditions. The conventional packaging materials have also had the problem of deteriorating water resistance, and especially poorer laminate strength after exposure to water.

SUMMARY OF THE INVENTION

[0008] It is a first object of the present invention to provide a vapor deposition film which allows direct viewing of contents and which has high age barrier propreties comparable to those of aluminum foil. In particular, there is provided a vapor deposition film which exhibits no peeling of the vapor deposition layer from the substrate or deterioration of its gas barrier properties even after boiling sterilization or retort sterilization, and without loss of laminate strength errexposure to water, thus promising a wide range of possible uses in packaging materials with general usefulness for foods, non-foods and the like.

[0009] It is a second object of the invention to provide a packaging material made using this vapor deposition film, which is a highly practicel packaging material with high gas barrier properties and with high resistance to setting the provided provided in the provided pr

sterilization or retort sterilization.

[0010] It is a third object of the invention to provide bag-like packages made using the packaging material, which are packages which undergo no deterioration in oxygen permeability or laminate strength after sterilization treatment, and which exhibit virtually no peeling of their vapor deposition layers from their substrates.

- [0011] In order to achieve the objects described above, the present invention provides a vapor deposition film comprising a substrate made of a transparent plastic material, a primer layer comprising a composition which contains a trifunctional organositien erepresented by the general formula RSi(OR), (wherein R' is a substituted or unsubstitude alloy group, vinyl group, etc. and R is an alkyl group, etc.) or a hydrolysate of the organositiane, an acryl polyol and an isocyanate compound, and a vapor deposition layer comprising an inorganic oxide in a thickness of 5~300nm, formed by successive lamination on at least one side of the substrate.
- [0012] The present invention further provides the aforementioned vapor deposition film wherein R' in the trifunctional organosilane is an alkyl group including an epoxy group or isocyanate group.
 - [0013] A reaction catalyst is preferably added to the aforementioned composition for the primer layer. In particular, the reaction catalyst may be a tin compound, and is preferably a tin compound selected from the group consisting of tin chloride, in oxychloride and tin alkoxides.
 - [0014] It is preferred to further add to the composition a metal alkoxide represented by the general formula M(OR), (wherein M is a metal element, Fis an alkyl group such as CH₂ Cyble, etc. and n is the oxidation number of the element or a hydrocystate of the metal floxidie. Here instruction alkoxide is preferably a metal selected from the grow constituin of SI. Alt. Zr and their mixtures.
- 10015] The thickness of the primer layer is preferred to be in the range of 0.01~2µm.
 - [0016] The inorganic oxide of the vapor deposition layer is preferably one selected from the group consisting of aluminum oxide, silicon oxide, magnesium oxide and their mixtures.
- [0017] An overcoasing layer may be also laminated on the vapor deposition layer, and it is preferred for the overcasting layer to be a layer obtained by apphying, heating and drying a coating agent composed mainly of an aqueous solutions or an aqueous/alcohol mixed solution containing a water-soluble polymer and either or both (a) at least one metal alkoxide or hydrolysate thereof and (b) in cholinde. Here, the metal alkoxide or preferably one selected from the proposition of totracthoxysilane, trilisopropoxysiuminum and mixtures thereof. The water-soluble polymer is proferably polyminy alcohol.
 - [0018] The invention still further provides a packaging material prepared by laminating the aforementioned vapor deposition film and a heat seal layer on the vapor deposition layer or the overcoating layer side.
 - [0019] The invention still further provides packages made into bag form using the aforementioned packaging material.

BRIEF DESCRIPTION OF THE DRAWINGS

- [0020] The present invention will now be explained in greater detail with reference to the drawings in which:
 - Fig. 1 is a partial cross-sectional view of a vapor deposition film according to an embodiment of the present invention:
- Fig. 2 is a partial cross-sectional view of a vapor deposition film according to another embodiment of the present invention;
 - Fig. 3 is a partial cross-sectional view of a packaging material prepared using a vapor deposition film according to yet another embodiment of the present invention; and
 - Fig. 4 is a perspective view of an embodiment of a package made using the packaging material shown in Fig. 3.

45 DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENTS

- [0021] Fig. 1 and Fig. 2 are cross-sectional views of vapor deposition films according to embodiments of the present invention
- [0022] In Fig. 1, the substrate 1 is affilm made of a plastic material. On the substrate 1 there are successively laminated of a primer layer 2 made of a composition comprising a triffunctional organsistiane, an earry leoylo and an isocyanizate compound, and a vapor deposition layer 3 containing an inorganic oxide. In Fig. 2, an overcoating layer 4 is further laminated thereon.
- [0023] The substrate 1 is a plastic material, and a transparent film is preferred to take a dvantage of the transparency of the vapor deposition layer. As examples of substrates there may be mentioned polyester films such as polyethyrine terophthalate (PET) and polyethylene naphthalate; polyedin films such as polyethylene and polypropylene; polyetyrene films; polyamotale films; polyamotale films; and polymid films; the substrate may be stretched or unstructed, and should have certain mechanical strength and dimensional stability. Particularly ordered among those are polyethylene terepthilaste films coolinadly stratched in biasizal directions. An

opposite side of the substrate to the side thereof on which the vapor deposition layer is formed may also be coated with thin-films formed from any of various well known additives and stabilizers, including antistatic agents, ultraviolet inhibitors, plasticizers, lubricants and the like. For better achieston with these thin-films, the coated side of the substrate may be subjected to any type of pretreatment, such as corona treatment, low-temperature plasma treatment, ion born-bardment treatment, chemical treatment, so the substrate of the product of the p

[0024] The thickness of the substrate is not under any particular restrictions, and from the standpoint of suitability as packaging materials, the film may be laminated with a film of a different nature than the film itself. From the standpoint of workability when forming the primer layer and inorganic oxide vapor deposition layer, as well as the overcoating layer, a practical range of 3–200µm is preferred, with 6–30µm being particularly preferred.

[0025] From a productivity standpoint, a long, continuous film is preferred which allows continuous formation of each of the aforementioned layers.

[0026] The primer layer according to the present invention is formed on the substrate made of a plastic material, and this layer serves to increase the adhesion between the substrate and the inorganic oxide vapor deposition layer, and to prevent peeling of the vapor deposition layer after boiling stefficiation, retort sterilization or autoclave sterilization.

5 [0027] As a result of much diligent research, the present inventors have found that compositions of trifunctional organosilanes or their hydrolysates with acryl polyol and isocyanate compounds can be used as the primer layer in order to achieve the aforementioned object of the present invention.

[0028] The composition of the primer layer will now be explained in detail.

[0029] The tiffunctional organosilane used according to the present invention is a compound represented by the general formula R'Si(CR), (wherein R' is a substituted or unsubstituted alley group, virily group, etc. and R is an allyl group, etc.). Here, the substitutent of R' preferably includes an epoxy group or isocyanate group. As specific exemplary compounds there may be mentioned eithyltimethoxysitene and viryltimethoxysilane and viryltimethoxysilane and viryltimethoxysilane where R' includes an epoxy group; and ry-isocyanate propyltimethoxysilane and epoxycycholaxylethyl timethoxysilane where R' includes an isocyanate group. These compounds may be used allone or in combinations of two or more.

[0303] The trifunctional organosaliane used according to the present invention may also be a hydrolysate of the compound represented by the general Inorula RSI(OR), (where R is a substituted or unsubstituted alkyl group, viryl group, etc. and R is an alkyl group, etc.). Here, the substituent of R' preferably includes an epoxy group. The same specific exempliary compounts given above apply.

10031] The process used to obtain hydrolysates of these compounds can be a known process involving direct addition of an acid or alkali to the trifunctional organisalisme.

[0032] The acryl polyol used according to the present invention is a polymer compound obtained by polymerizing an acrylic acid derivative monomer or a copolymer compound obtained by copolymerizing an acrylic acid derivative monomer and another monomer, the (co)polymer compound also having a terminal hydroxyl group so as to react with the locoyanate group of the isocyanate compound which is subsequently added. Among such compounds it is preferred to use acryl polysis obtained by simple polymerization of acrylic acid derivative monomers such as ethyl (meth)acrylate, hydroxyethyl (meth)acrylate, hydroxyproxyll (meth)acrylate and hydroxybutyll (meth)acrylate, or obtained by copolymerization through addition of another monomer such as styrene. From the standpoint of reactivity with the isocyanate compound. It is preferred for the hydroxy value to be between 5 and 200 (KOHmoy).

40 [0033] The mixing ratio of the acryl polyol and the trifunctional organosilane is preferably in the range of 1/1 to 100/1, and more preferably in the range of 2/1 to 50/1, in terms of weight ratio.

[0034] No catalyst is necessary when combining the acryl polyol with the trifunctional organosilane when I'n the soformentioned general formula includes an isocyanate group. Addition of a reaction catalyst is preterred, however, when combining the acryl polyol with a trifunctional organosilane other than a trifunctional organosilane with an isocyanate group, in order to promote the reaction. From the standpoint of reactivity and polymerization stability, the catalyst added is preferably a time compound such as tin chloride (SnCl₂, SnCl₄), in oxychloride (SnCHCl, SnCH)₂Cl₂), at the alkoxide or the like. These catalysts may be added directly during mixing, or they may be dissolved in a software sometime of the distribution of the

[0035] The isocyanate compound used for the present invention is added for the purpose of increasing adhesion between the substrate and the inorganic oxide vapor deposition layer by the urethane bond which results from reaction with the early ployd, and it functions primarily as a crosslinking or hardening agent. Isocyanate compounds which can be used to achieve this object include monomers such as an aromatic monomer, aliphatic monomer such as tolylene discoyanate (ZNI). Nexamethylene discoyanate (ZNI). Nexamethylene discoyanate (ZNI) assembleting the control isocyanate (ZNI) as well as their polymers and derivatives. They may be used alone or in combinations.

[0036] The mixing ratio of the acryl polyol and the isocyanate compound is not particularly restricted, but if the iso-

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cyanate compound is deficient the hardening may not be satisfactory, and if it is excessive, blocking may occur creating problems for working. The mixing ratio of the acryl polyol and the isocyanate compound is therefore preferred to be such that the number of isocyanate groups of the isocyanate compound is no greater than 50 times the number of hydroxyl groups of the acryl polyol. It is more preferable for the isocyanate groups and hydroxyl groups to be at an equivalent ratio. The mixing method may be any publicly known one and is not particularly restricted.

[0037] For enhanced solution stability when preparing the solution of the composition, a metal alkoxide or its hydrohysate may be added. The metal alkoxide is a compound represented by the general formula M(OR), wherein M is a metal such as Si, Al, Ti or 2r and R is an alkyl group such as CH₃ or C₂H₃. Specifically there may be mentioned tetraethoxysilane [Si(OC₂H₃)₄] and tripropoxysilaminum [Al(OC₃H₃)₄]. Among these are preferred tetraethoxysilane, tripropoxysilaminum and mixtures thereof, because of their relative stability in aqueous solvents. The method used to obtain a hydrohysate of the methal alkoxide may involve hydrohysis with the aforementioned trifunctional organosilane, or the metal alkoxide may be added esperately.

[0038] The mixing ratio of the trifunctional organosilane and the metal alkoxide is preferably in the range of a molar ratio of 10:1 to 1:10 from the viewpoint of solution stability. It is more preferred for these to be combined at an equimolar

[0039] There are no particular restrictions on the coated film of this composition, and for example, a solution prepared by any of the following methods may be coated onto the substrate.

 A solution prepared by mixing the acryl polyol and isocyanate compound with the product of prior hydrolysis reaction of the trifunctional organosilane (where the aforementioned reaction catalyst may be used);

2) A solution prepared by mixing the acryl polyol and isocyanate compound with the trifunctional organosilane which has undergone hydrolysis reaction with a metal alkoxide (where the aforementioned reaction catalyst may be used):

3) A solution prepared by first mixing the trifunctional organosilane and the early polyol in a solvent (where the aforemention and reaction catalyst and metal alkoxide may also be added), subjecting the mixture to hydrolysis reaction, and then adding the isocyanate compound to the product thereof;

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4) A solution prepared by adding the isocyanate compound to a simple mixture of the trifunctional organosilane and the acryl polyol (where the aforementioned reaction catalyst and metal alkoxide may also be added).

[0040] Various additives, for example, hardening accelerators such as tertiary amines, imidazole derivatives, carboxylic acid metal salt compounds, quaternary ammonium salts, and quaternary phosphonium salts, antioxidants such as phenol-based antioxidants, sulfur-based antioxidants and phosphite-based antioxidants, leveling agents, flow adjustors, catalysts, crosslinking reaction accelerators, fillers and the like may also be included depending on the need. [0041] The solvent or dilution solvent in the solution used to form the primer layer is not particularly restricted so long as it is capable of dissolving or diluting each of the components forming the primer layer. For example, when a trifunctional organosilane is used, an ester such as ethyl acetate or butyl acetate is appropriate, and when a trifunctional organosljane hydrolysate is used, a mixed solvent of an ester with an alcohol such as methanol, ethanol or isopropyl alcohol is appropriate. In addition to these solvents, ketones such as methyl ethyl ketone and aromatic hydrocarbons such as toluene and xylene may also be used alone or in any desired combination. In particular, since aqueous solutions of hydrochloric acid and the like are sometimes used for hydrolysis of infunctional organosilanes, it is important to use a mixed solvent of the polar solvent such as ethyl acetate in admixture with isopropyl alcohol or the like as a co-solvent. [0042] The thickness of the primer layer is not particularly restricted as long as a uniform coated film is formed. However, the dry film thickness (solid portion) is generally preferred to be in the range of 0.01~2um. If the thickness is less than 0.01 µm it becomes difficult to obtain a uniform coated film, and the adhesion will sometimes be reduced. If the thickness exceeds 2um, it becomes impossible to maintain flexibility of the coated film because of its thickness. while the risk of cracking of the coated film due to external factors also becomes a concern. A particularly preferred range for the thickness of the primer layer is from 0.05~0.5μm.

[0043] The method used to form the primer layer may be, for example, a well known printing process such as offset printing, site vices printing, site, or a well known application process such as roll coaling, knile edge coaling, gravure coaling, drayure coaling

[0044] The inorganic oxide vapor deposition layer is a vapor deposition layer of an inorganic oxide comprising aluminum oxide, sliicon oxide, tin oxide, magnesium oxide or a mixture thereof. The layer should be transparent and have gas barrier properties against oxygen, water vapor, etc. Particularly preferred among these are aluminum oxide and sliicon oxide. However, the vapor deposition layer of the present invention is not limited to the above-mentioned inorganic oxides. And are without material may be used which meets the aforementioned requirements.

[0045] The optimum thickness of the vapor deposition layer will depend on the type and structure of the inorganic oxide used, but it is generally preferred to be appropriately selected within a range of 5-300mm. If the film thickness is less than 5 mit may not be possible to obtain a uniform film and the film thickness may be inadequate, which may

prevent it from adequately carrying out its function as a gas barrier material. If the film thickness is over 300cm, it becomes impossible to maintain teachility of the thin-film, presenting the fisk of cracking of the thin-film due to external factors such as bending and stretching after formation of the film. A preferred range for the thickness of the vapor deposition layers is from 10 to 150mm.

- 5 [0046] Many different methods exist for formation of the inorganic oxide vapor deposition layer on the primer layer, and common vacuum vapor deposition may be employed. Other thin-fill norming methods, such as sputtering ion plating and plasma vapor/hase growth methods (CVD) may also be used. From the standpoint of productivity, however, vacuum vapor deposition is a superior method at the current time. The healing means used for vacuum vapor deposition is preferably an electron beam heating system, resistance heating system or induction heating system. For induction heating system or induction heating system. For induction heating system is related to the vapor deposition layer, the vapor deposition may be accomplished by the plasma assist method or ion beam assist method. For higher transparency of the vapor deposition film, the vapor deposition reaction may be carried out while blowing in oxygen gas or the like.
 - [0047] An overcoating layer is optionally formed on the inorganic oxide vapor deposition layer in order to provide higher gas barrier properties depending on the quality demanded.

[0048] The overcoating layer is formed using a coating agent composed mainly of an aqueous solution or aqueous alcohol mixed solution which contains an water-soluble ophymer and either or both (a) at least one metal alkoxide or hydrobysate thereof and (b) in choride. This may be, for example, a solution prepared by dissolving the water-soluble polymer and tin chloride in an aqueous (water or water/alcohol mixture) solvent, or such a solution modified by mixture with a metal alkoxide directly or after its hydroblys or other treatment. After coating of the solution not the inorganic oxide vapor deposition layer, it is heated and dried to form the layer. The various components included in the coaling agent will now be described in further detail.

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[0449] As water-soluble polymers to be used in the coaling agent according to the present invention there may be mentioned polymyla plachol, polymylay profilence, starch, methyl cellubes, cestowymethyl cellubes, esclared, polymyla, etc. Polyvinyl alcohol (hereunder, elimply called as PVA) in particular has the most excellent gas barrier property whete used in the coating agent of the present invention. PVA is generally obtained by spannification of polymyla gable. The PVA is not particularly restricted and includes, for example, partially sepontified PVA wherein 10%, 20% or more of the acceletal crouses remain, or total PVA wherein only a few percent of the acceletal crouses remain.

[0050] The tin chloride used in the coating agent may be stannous chloride (SnCl₂), stannic chloride (SnCl₄) or a mixture thereof. These tin chloride compounds may be anhydrates or hydrates.

[0051] The metal alkoxide is a compound represented by the general formula M(OFI), wherein M is a metal such as Si, Ti, A for Zr and R is an alkyl group such as CH₂ or C₂H₃. Specifically there may be mentioned tetraethoxysilane [Si (CC₂H₃), all and triscopropoxyaluminum [Al(O₂-2-3₂H₇)], tetraethoxysilane and triscopropoxyaluminum being preferred because of their relative stability in aqueous solvents after hydrolysis.

[0052] If necessary, a publicly known additive such as an isocyanate compound or silane coupling agent or a dispersing agent, stabilizer, viscosity adjustor, coloring agent or the like, may be added to an extent which does not impair the gas barrier properties of the coating agent.

[00:53] Preferred examples of isocyanate compounds which may be added to the coating agent include ones having two or more isocyanate groups in the molecule. For example, there may be mentioned tolylene disocyanate, here my mentioned tolylene disocyanate, and the properties of the properties of the properties and other such monomers, as well as their polymers and derivatives.

[0054] The method for applying the coaling agent may employ a publicly known means for commonly used dippling methods, roll coating methods, screen printing methods, spray methods and the like. The thickness of the coated film will differ depending on the type of coaling agent and the working conditions; the post-drying thickness may be 0.01 µm or greater, but if the thickness exceeds 50 µm cracks will tend to occur in the film, and therefore the range of 0.01 —50 µm is oreferred.

[0055] Other layers may also be laminated over the inorganic oxide vapor deposition layer or the overcoating layer. Examples thereof include printed layers, interlayer films, heat seal layers, etc.

[0056] A printed layer is formed for practical application as a packaging bag or the like. It is, for example, a layer composed of an ink prepared by adding an additive such as any of various pigments, extender pigments, plasticizers, desiccators, stabilizers and the like, to a conventionally employed ink binder realin which is urethane-based, acyplic-based, nitrocellulose-based, rubber-based, with childred-based, det. The printing forms characters, images and the like. The forming process may be a well known printing practices may be a well known printing practices may be a well known printing practices and process such as offset printing, gravure printing or silk even printing or all well process such as real coating, knife edge coating or gravure coating. The dry film it thickness fool dortion of the printed layer may be from 0.1 to 2 Jum.

[0057] An interlayer film is formed between the vapor deposition layer or overcoating layer and the heat seal layer in order to increase the rupture strength during bolling or retort sterilization, and from the standpoint of mechanical strength and thermal stability, penerally it must be of a type selected from among basially stretched rylon films, bisance.

stretched polyethylene terephthalate films and biaxially stretched polypropylene films. Its thickness will be determined based on the material and the demanded quality, but it is generally in the range of 10-30µm. The method of lamination may be a publicly known one such as dry lamination involving attachment using an adhesive agent such as a two-part curing type unthane-based resin.

- [00:58] A heat seal layer is provided as an adhesive layer when forming bag-like packages. Examples of resins which may be used for the heat seal layer include polyethylene, polypropylene, ethylene-vinyl acetate copolymer, ethylene-methacrylic acid ester copolymer, ethylene-acrylic acid ester copolymer, and metal crosslinked forms thereof. The thickness will be determined based on the purpose, but it is generally in the range of 15-200µm. The method of lamination will generally be a method such as or dy lamination involving attachment of a film of the resin using an adhesive agent such as a two-part curing type urethane-based resin, but other publicly known methods may be used for the lamination.
 - [0059] A packaging material employing a vapor deposition film according to the present invention can be used as a packaging material in the field of foods, non-foods and medicines. In particular, when it is used as a packaging material for boiling sterilization, retort sterilization or autoclave sterilization, it gives a packaging material with excellent transparency and gas barrier properties while also avoiding the problem of peeling, etc.
 - [0060] Any form of packaging is possible as a packaging employing the packaging material of the invention, and as examples there may be mentioned three-side sealed pouches, four-side sealed pouches, standing type pouches, pillow type pouches and the like. The packaging may also be in a form with a cover sealing the opening of an open container. A publicly known method may be used as the shaping method.
- [0061] Fig. 3 is a cross-sectional view of the layer structure of a packaging material according to an embodiment of the invention. In this drawing, reference numeral 1 denotes a substrate, 2 a primer layer, 3 a vapor deposition layer, 4 an overcosting layer, 5 an achieve layer, 6 an interlayer film, 7 another adhesive layer and 8 a heat seal layer. The heat seal layers of packaging materials constructed in this fashion are attached together and heat sealed, to form a standing two pouch such as shown in Fig. 4, for example.

[Examples]

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[0062] A packaging material employing the vapor deposition film of the present invention will now be further explained with reference to concrete examples, with the understanding that the invention is not limited to these examples so long as the dist thereof is maintained.

(Preparation of primer layer solution)

[0063]

- A) In a diluting solvent (ethyl acatale) 2-(epoxycyclohexyl)athyl trimethylsiane (hercunder, simply called as EETMS) and acryl polyol at a 5.04oid amount (welght ratio) with respect to the EETMS were mixed. A tin chioride (SnCbylmethanol solution (prepared to 0.003 molyg) was further added to the mixture as a catalyst to 1/135 mol with respect to the EETMS, and the mixture was stirred. Tolylene discoyanate (hereunder, simply called as TDI) was then added at an equivalent of socyanate groups in the TDI with respect to hydroxyl groups in the acryl polylo. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution
- B) In a diluting solvent (isopropyl alcohol/ethyl acetate) EETMS and tetraethoxysilane (Si(OC₂H₂)₄: hereunder, simply called as TEOS) were mixed at a molar ratio of 1:1. To this mixture there were added acryl polyol at a 25-fold amount in terms of weight and a tin chloride (SnCt₂)/methanol solution (prepared to 0.003 moly) as a catalyst at an amount of 1/400 mol with respect to the mixture, and the mixture was stirred. Next, 0:1 N hydrochloric acid was added and an equivalent of isocyanate groups in the TDI with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution B.
- C) In a diluting solvent (isopropyl alcohol/ethyl acetate) EETMS and TEOS were mixed at a molar ratio of 1:1. To this mixture there was added acryl polyol at a 2.5-fold amount in terms of weight. TDI was then added at an equivalent of isocyanate groups in the TDI with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution C.
- D) In a diluting solvent (ethyl acetate), TDI was added as an isocyanate compound to acryl polyol at an equivalent of isocyanete groups in the TDI with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution D.
 - E) In a diluting solvent (ethyl acetate), 5 parts by weight of acryl polyol was mixed with 1 part by weight of γ isocyanate propyltrimethoxysilane, and the mixture was stirred. TDI was then added as an isocyanate compound

- at an equivalent of isocyanate groups in the TDI with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution E.
- F) In a diluting solvent (ethyl acetate), 5 parts by weight of acryl polyol was mixed with 1 part by weight of y acceptance prophime-browsysilene, and the mixture was stirred. XDI was then added as an isocyanate compound at an equivalent of isocyanate groups with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution F.
 - G) In a dikting solvent (eltryl acetate), 5 parts by weight of acryl polyol was mixed with 1 part by weight of -isocynate propytrimethoxysilane, and the mixture was stirred. A 7:3 mixture of XDI and IPDI as isocynate compounds was then added at an equivalent of isocynate groups in the isocynate compound mixture with respect to hydroxyl groups in the acryl polyol. The mixed solution was diluted to 2% by weight as a total concentration of the added components to make solution 6.

(Example 1)

- 15 [0064] On one side of a 12-µm thick biaxially stretched polyethylene terephthalate (PET) film as the substrate 1, the solution A was coated and dried by grawure ceating to a dry film thickness of 0.2µm, to form a primer layer 2. An electron beam heating-type vacuum vapor deposition apparatus was then used for vaporization of metallic aluminum, and oxygen gas was introduced therein to form an aluminum oxide vapor deposition layer 3 to a thickness of 20mm on the primer layer 2. A coating agent with the composition described below was further coated thereon by grawure coating.
 20 After coaling, it was dried at 120°C for one minute to form a 0.3-µm thick overcoating layer 4, thus yielding a vapor deposition film.
 - Composition of coating agent: Mixture of solution (1) and solution (2) below at a mixing ratio (wt%/wt%) of 60/40.
- 25 [0065] Solution (1): Hydrolyzed solution with solid portion of 3 wt% (as SiO₂) prepared by adding 89.6 g of hydrochloric acid (0.1 N) to 10.4 g of tetraethoxysilane and stirring for 30 minutes for hydrolysis.
 - [0066] Solution (2): Water/Isopropyl alcohol solution (water:isopropyl alcohol weight ratio = 90:10) containing 3 wt% polyvinyl alcohol.
- [0067] The overcosting layer 4 of the resulting vapor deposition film was laminated with a blackally stretched nylon film with a thickness of 15 year, as an interlesy film 6 by dy lamination, via a two-part curing type urethane-based adhesive, and then a 70-µm thick polypropylene film was laminated as a heat seal layer 6 by dry lamination via a twopart curing five urethane-based adhesive, to fabricate a packaging material.

(Example 2)

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- [0068] A packaging material was obtained in the same manner as Example 1, except that the vapor deposition layer 3 in Example 1 consisted of silicon oxide at a thickness of about 40nm obtained by vacuum vapor deposition with a resistance healing system.
- 40 (Example 3)
 - [0069] A packaging material was obtained in the same manner as Example 1, except that the solution B was used as the primer layer 2 in Example 1.
- 45 (Example 4)
 - [0070] A packaging material was obtained in the same manner as Example 1, except that the solution C was used as the primer layer 2 in Example 1.
- 50 (Example 5)
 - [0071] A packaging material was obtained in the same manner as Example 1, except that the solution E was used as the primer layer 2 in Example 1.
- 55 (Example 6)
 - [0072] A packaging material was obtained in the same manner as Example 1, except that the solution F was used as the primer layer 2 in Example 1.

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(Example 7)

[0073] A packaging material was obtained in the same manner as Example 1, except that the solution G was used as the primer layer 2 in Example 1.

(Comparative Example 1)

[0074] A packaging material was obtained in the same manner as Example 1, except that the primer layer 2 in Example 1 was not formed.

(Comparative Example 2)

[0075] A packaging material was obtained in the same manner as Example 1, except that the solution D was used as the primer layer in Example 1.

(Test 1)

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[0076] The packaging materials of the present invention according to Examples 1-7 and the packaging materials according to Comparative Examples 1-2 which were fabricated in the manner described above were used to make pouches with the 4 sides as the sealing portions, and each was filled with 150 g of water as the contents. Retort sterilization was then carried out at 121°C for 30 minutes. The evaluation was based on the oxygen permeability before and after the retort sterilization (using an oxygen permeation measuring apparatus (OXTRAN-10/50A by Modern Control Co.) for measurement in an atmosphere of 30°C, 70%RH, units: cc/m2/day), the laminate strength (measured by peel rate at 300mm/min, units: gr/15 mm) and the visually observed state of peeling between the substrate and the vapor deposition layer after retort sterilization. The state of peeling was determined by observing the peeling of the vapor deposition layer upon 180-degree bending of the pouch seal sections after retort sterilization. The results are listed in Table 1.

[0077] The symbols used in Table 1 to indicate the evaluation results for the appearance of peeling after retort ster-Ilization are as follows.

- (ii): No peeling
- X: Peeling

[0078] The symbols used in Table 1 for the overall evaluation results are as follows.

- (ii): Good
- ×: Unusable

| 40 | | Table 1 | | | | | | |
|----|------------|--------------------------------|----------------------------|--------------------------------|----------------------------|---------------------------------------------|--------------------|--|
| | | Oxygen permeability | | Laminate strength | | Appearance after retort sterilization | Overall evaluation | |
| 15 | | Before retort sterilization | After retort sterilization | Before retort sterilization | After retort sterilization | | | |
| | Example 1 | 0.34 | 0.52 | 580 | 580 | 0 | 0 | |
| | Example 2 | 0.41 | 0.43 | 570 | 510 | 0 | 0 | |
| 50 | Example 3 | 0.38 | 0.47 | 450 | 420 | · @ | 0 | |
| | Example 4 | 0.51 | 0.48 | 500 | 450 | 0 | 0 | |
| | Example 5 | 0.69 | 0.80 | 590 | 330 | 0 | 0 | |
| 56 | Example 6 | 0.63 | 0.77 | 540 | 340 | 0 | 0 | |
| ~ | Example 7 | 0.72 | 0.81 | 630 | 350 | 0 | 0 | |
| | Comp.Ex. 1 | 0.34 | 1.08 | 460 | 100 | × | × | |

Table 1 (continued)

| | Oxygen permeability | | Laminate strength | | Appearance after retort sterilization | Overall evaluation |
|------------|--------------------------------|----------------------------|--------------------------------|-------------------------------|---------------------------------------------|-----------------------|
| | Before retort sterilization | After retort sterilization | Before retort sterilization | After retort sterilization | | |
| Comp.Ex. 2 | 0.42 | 0.74 | 540 | 300 | × | × |

[0079] Table 1 shows that the vapor desposition films to the present inservation according to Examples 1-7 and the packaging materials employing above have sufficient transparency to allow direct vibroning of their contents. The name ples of the present invention have high pass barrier properties to block gasten which can affect the contents, as well as high laminate strength. Even after text statistization there is no determination of the present invents, the present present invents are the present prese

[0080] In comparison, the packaging materials of Comparative Examples 1 and 2 also have sufficient transparency to allow direct viewing of the contents, and prior to retort startilization they had high gas barrier properties to block gases which can affect the contents, as well as high atminate strength. After retort sterilization, however, it is seen that the gas barrier properties of the packages deteriorated, the laminate strength was lowered, peeling occurred, and the retort sterilization resistance was poor.

(Example 8)

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- 5 [0081] On one side of a 12-µm thick biaxially stretched polyethylene terephthelate (PET) film as the substrate 1, the solution E was coated by gravure coating and dried to a dry film thickness of 0.2µm, to form a primer layer 2. An electron beam heating-type vacuum vapor deposition apparatus was then used for vaporization of metallic aluminum, and oxygen gas was introduced therein to form an aluminum oxide vapor deposition layer 3 to a thickness of 20nm on the primer layer 2.
- 30 [0082] A 30-µm thick polypropylene film was laminated as a heat seal layer on the resulting vapor deposition layer 3 by dry lamination via a two-part curing type urethane-based adhesive, to fabricate a packaging material.

(Comparative Example 3)

35 [0083] A packaging material was obtained in the same manner as Example 8, except that the primer layer 2 in Example 8 was not formed.

(Test 2)

[0084] The packaging material of the present invention according to Example 8 and the packaging material according to Comparative Example 9 within were tainfraction in the manner described above were used for measurement of the laminate strength between the vapor deposition layer and the heat seal layer (measured at a poel rate of 300 mm/min, units; grif 5 mm). The laminate strength was been essured in a similar manner while running a small amount of tap water over the pecling surface between the vapor deposition layer and the heat seal layer. The results are listed in Table 2

Table 2

| | Laminate strength | | |
|-----------|-----------------------|--------------------|--|
| | Without running water | With running water | |
| Example 8 | 640 | 540 | |
| Comp.Ex.3 | 660 | 50 | |

[0085] As is clear from the explanation given above, vapor deposition films according to the present invention and packaging materials employing them have a construction wherein formation of a primer layer with excellent dimensional stability and achesion even after boiling starlization or retort starlization on a transparent plastic substrate is followed by larmination of a vapor deposition laver made of an increasing code with excellent case barrier procerties. They therefore.

have transparency which all leads the control to be directly of level, as being leading to the control to be directly of level, as well as high gas barrier between the properties operation player leading to the control to those of all uniforms which is the control to the cont

5 [0086] While the presently preferred embodiments of the present invention have been shown and described, it will be understood that the present invention is not limited thereto, and that various changes and modifications may be made by those skilled in the art without departing from the scope of the invention as set forth in the appended claims.

10 Claims

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- 1. A vapor deposition lim comprising a substrate mate of a plastic material, a primer layer comprising a composition containing a trifunctional organosaliane represented by the general formula R'Si(OR)₃ (wherein R' is a substituted or unsubstituted allyl group, vinyl group, etc. and R is an allyl group, etc.), an acryl polylo and an isocyanate compound, and a vapor deposition layer comprising an inorganic oxide to a thickness of 5~300nm, formed by successive lamination on at least one side of said substrate.
 - A vapor deposition film according to claim 1, wherein R' in the structure of said trifunctional organosilane is an alkyl group including an epoxy group.
 - 3. A vapor deposition film according to claim 1 or 2, wherein a reaction catalyst is added to said composition.
 - 4. A vapor deposition film according to claim 3, wherein said reaction catalyst is a tin compound.
- A vapor deposition film according to claim 4, wherein said tin compound is a tin compound selected from the group consisting of tin chloride, tin oxychloride and tin alkoxides.
 - A vapor deposition film according to claim 1, wherein R' in the structure of said trifunctional organosilane is an alkyl group including an isocyanate group.
 - A vapor deposition film according to any one of claims 1 to 6, wherein a metal alkoxide represented by the general
 formula M(OH), (wherein M is a metal element, R is an alkyl group such as CH₃, C₂H₃, etc. and n is the oxidation
 number of the metal element) or a hydrolysate of said metal alkoxide is further added to said composition.
- A vapor deposition film according to claim 7, wherein the metal of said metal alkoxide is a metal selected from the group consisting of Si, Al, Ti, Zr and their mixtures.
 - 9. A vapor deposition lim comprising a substrate made of a plastic material, a primer layer comprising a composition containing a hydrolysate of a trifunctional organositane represented by the general formula R'Si(OR)₃ (wherein R' is a substituted or unsubstituted alkyl group, vin'yl group, etc. and R is an alkyl group, etc.), an acryl polyol and an isocyanate compound, and a vapor deposition layer comprising an inorganic oxide to a thickness of 5-300nm, formed by successive lamination on at least one side of said substrate.
 - A vapor deposition film according to claim 9, wherein R' in the structure of said trifunctional organosilane is an alkyl group including an epoxy group.
 - 11. A vapor deposition film according to claim 9 or 10, wherein a reaction catalyst is added to said composition.
 - 12. A vapor deposition film according to claim 11, wherein said reaction catalyst is a tin compound.
 - 13. A vapor deposition film according to claim 12, wherein said tin compound is a tin compound selected from the group consisting of tin chloride, tin oxychloride and tin alkoxides.
- 14. A vapor deposition film according to any one of claims 9 to 13, wherein a metal alkoxide represented by the general formula M(OR), (where M is a metal element, R is an alkyl group such as CH₃, C₂H₃, etc. and n is the oxidation number of the metal element) or a hydrolysate of said metal alkoxide is further added to said composition.
 - 15. A vapor deposition film according to claim 14, wherein the metal of said metal alkoxide is a metal selected from

the group consisting of Si, Al, Ti, Zr and their mixtures.

- A vapor deposition film according to any one of claims 1 to 15, wherein the thickness of said primer layer is in the range of 0.01~2um.
- 17. A vapor deposition film according to any one of claims 1 to 16, wherein said inorganic oxide is one selected from the group consisting of aluminum oxide, silicon oxide, magnesium oxide and their mixtures.
- 18. A vapor deposition film according to any one of claims 1 to 17, wherein an overcoating layer is additionally laminated on said vapor deposition film, said overcoating layer being a layer obtained by applying, heating and drying a coating agent composed mainly of an aqueous solution or an aqueous/alcohol mixed solution containing a watersoluble polymer and either or both (a) at least one metal alkoxide or hydrolysate thereof and (b) fin chloride.
 - A vapor deposition film according to claim 18, wherein said metal alkoxide is one selected from the group consisting
 of tetraethoxysilane, triisopropoxyaluminum and mixtures thereof.
 - 20. A vapor deposition film according to claim 18 or 19, wherein said water-soluble polymer is polyvinyl alcohol.
- 21. A packaging material comprising a vapor deposition film according to any one of claims 1 to 20, and a heat seal layer laminated on the vapor deposition layer or overcoating layer side thereof.
 - 22. A package formed into a bag using a packaging material according to claim 21.

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Fig.1

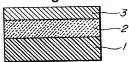


Fig.2

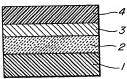
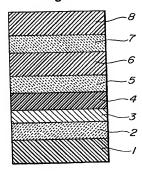
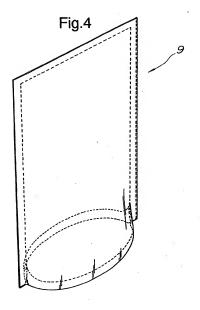


Fig.3





INTERNATIONAL SEARCH REPORT

ording to International Patent Classification (IPC) or to both national classification and IPC

Minimum documentation searched (classification system followed by classification symbols)
Int.Cl⁶ B32B9/00-35/00

CLASSIFICATION OF SUBJECT MATTER Int.Cl* B32B9/00

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B. FIELDS SEARCHED

International application No. PCT/JP99/00848

| Jits | tion searched other than minimum documentation to it uyo Shinan Koho 1926–1996 i. Jitsuyo Shinan Koho 1971–1999 | be extent that such documents are included Toroku Jitsuyo Shinan Koh Jitsuyo Shinan Toroku Koho | io 1994-1999 | | | |
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| | lata base consulted during the international search (na | me of data base and, where practicable, se | rarch terms used) | | | |
| | OCUMENTS CONSIDERED TO BE RELEVANT | | | | | |
| Category* | Citation of document, with indication, where a | | Relevant to claim No. | | | |
| P | JP, 10-264292, A (Toppan Pr 6 October, 1998 (06. 10. 98) Claims (Family: none) | | 1-22 | | | |
| A | P, 10-156996, A (Daicel Chemical Industries, Ltd.), 1-22 6 June, 1998 (16. 06. 98), laims (Family: none) | | | | | |
| A | A JP, 10-725, A (Toppan Printing Co., Ltd.), 1-22 6 January, 1998 (06. 01. 98), Claims (Family: none) | | | | | |
| A | JP, 10-722, A (Toppan Print. 6 January, 1998 (06. 01. 98) Claims (Family: none) | ing Co., Ltd.), | 1-22 | | | |
| A JP, 9-314725, A (Toppan Print 9 December, 1997 (09. 12. 97), Claims (Pamily: none) | | nting Co., Ltd.),), | 1-22 | | | |
| × Furthe | r documents are listed in the continuation of Box C. | See patent family annex. | | | | |
| . Special exception of closed decreasance of the de | | | | | | |
| | ectual completion of the international search pril, 1999 (27. 04. 99) | Date of mailing of the international seam 11 May, 1999 (11. 0 | ch report)5 . 99) | | | |
| | ailing address of the ISA/ | Authorized officer | | | | |

INTERNATIONAL SEARCH REPORT

International application No. PCT/JP99/00848

| C (Continua | ation). DOCUMENTS CONSIDERED TO BE RELEVANT | | |
|-------------|---------------------------------------------------------------------------------------------------|-------|----------------------|
| Category* | Citation of document, with indication, where appropriate, of the relevant | | Relevant to claim No |
| A | JP, 9-123333, A (Sumitono Bakelite Co., L 13 May, 1997 (13. 05. 97), Claims (Family: none) | td.), | 1-22 |
| A | JP, 10-128936, A (Diafoil Hoechst Co., Ltd 19 May, 1998 (19. 05. 98), Claims (Family: none) | 1.), | 1-22 |
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